


FORM PTO-1449	Atty. Docket No.: P32.12-0006	Appl. No.: 09/855,179
<p>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</p> 	First Named Inventor:	
	Evren Eryurek et al.	
	Filing Date	Group Art:
	May 14, 2001	2661

## U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
XS	AA	4,668,473	05/26/86	Agarwal	422	62
	AB	4,720,806	01/19/88	Schippers et al.	364	551
	AC	5,089,979	02/18/92	McEachern et al.	364	571.04
	AD	5,436,705	07/25/95	Raj	355	246
	AE	5,526,293	06/11/96	Mozumder et al.	364	578
✓	AF	5,539,638	07/23/96	Keeler et al.	364	424.03
	AG					
	AH					
	AI					
	AJ					
	AK					

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## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Sub Class	Translation Yes No
XS	AL	EP 0 512 794 A2	11/11/92	EPO			X
XS	AM	JP 03229124	10/11/91	Japan			(Abstract Only)
	AN						

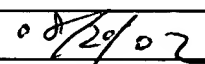
## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

XS	AO	"On-Line Tool Condition Monitoring System With Wavelet Fuzzy Neural Network," by Li Xiaoli et al., pp. 271-276 (1997).
<del>XS</del>	AP	
	AQ	

EXAMINER:



DATE CONSIDERED:



EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.